



Our Docket No: 42P11369

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Fred Chen, et al.

Serial No: 10/040,772

Filed: January 4, 2002

For: An Active Secondary Exposure  
Mask To Manufacture Integrated  
Circuits

Examiner: Rosasco, Stephen D.

Art Unit: 1756

RESPONSE TO OFFICE ACTION

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed February 16, 2005, the Applicants respectfully request that the Examiner enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that I am causing the above-referenced correspondence to be deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and that this paper or fee has been addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

June 16, 2005

Date of Deposit

Krista Mathieson

Name of Person Mailing Correspondence

Signature

Date

06/21/2005 CCHAU1 00000049 10040772

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